

2499-5

**International Training Workshop on FPGA Design for Scientific
Instrumentation and Computing**

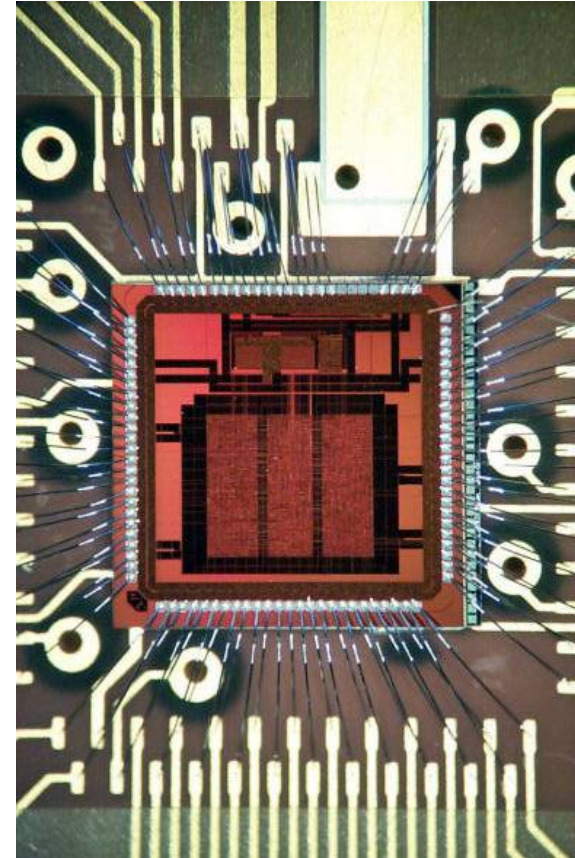
11 - 22 November 2013

**Introduction to VLSI Digital Design
The CMOS Inverter**

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Switzerland*

Outline

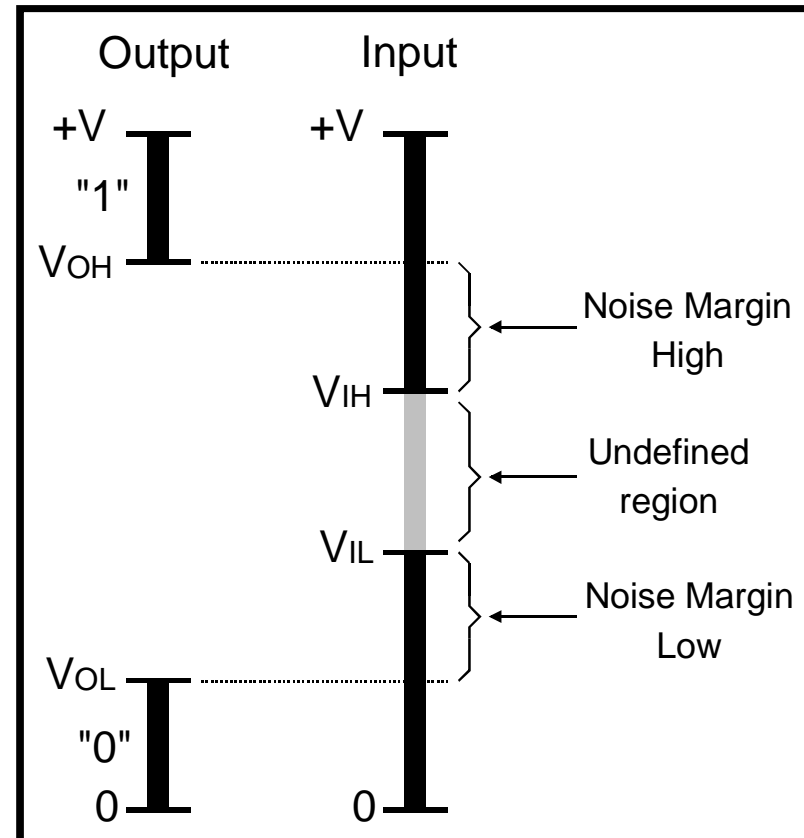
- Introduction
- Transistors
- **The CMOS inverter**
 - DC operation
 - Dynamic operation
 - Propagation delay
 - Power consumption
 - Layout
 - Delays
- Technology
- Scaling
- Gates
- Sequential circuits
- Storage elements



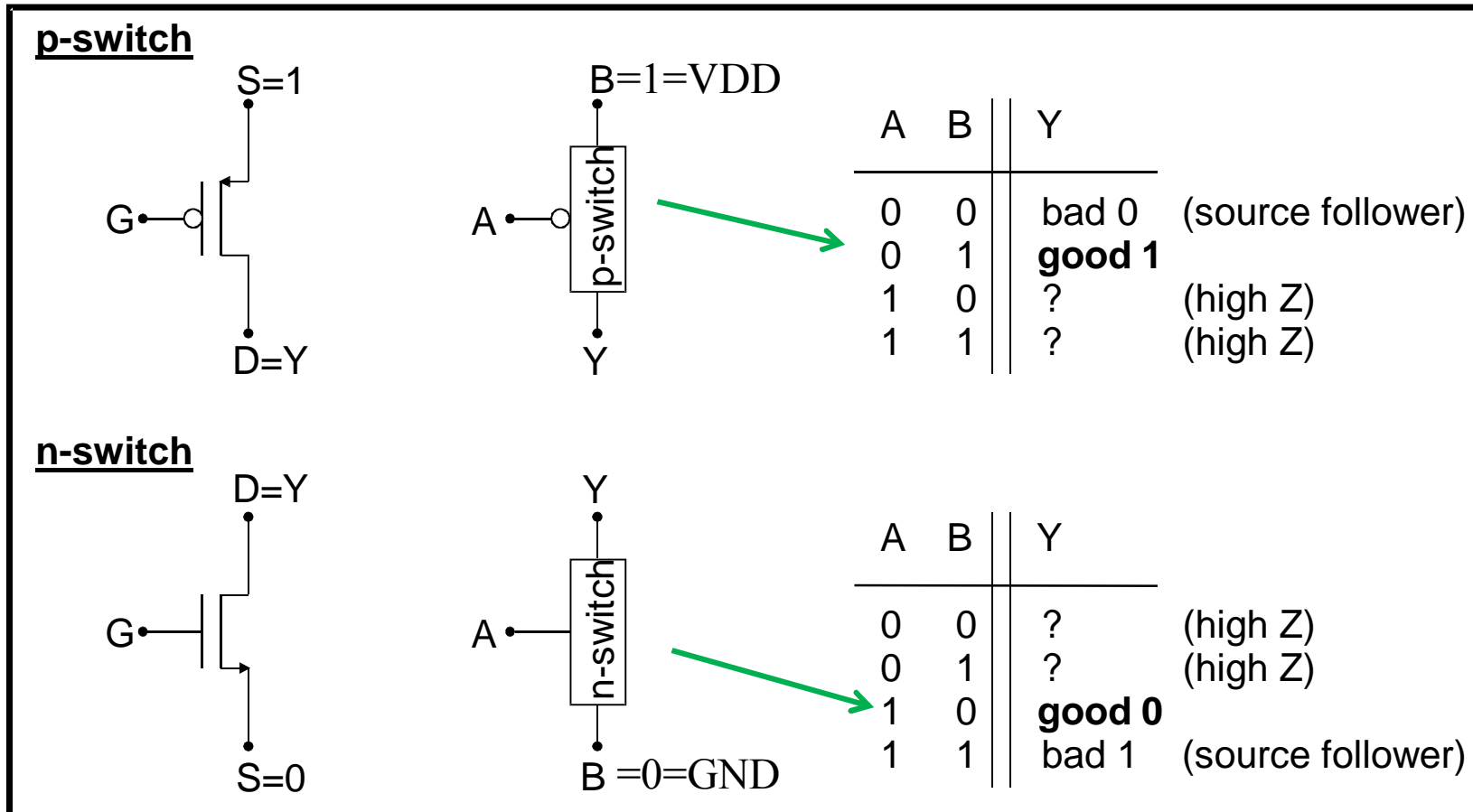
Many slides are a courtesy of Paulo Moreira

CMOS logic: "0" and "1"

- Logic circuits process Boolean variables
- Logic values are associated with voltage levels:
 - $V_{IN} > V_{IH} \Rightarrow "1"$
 - $V_{IN} < V_{IL} \Rightarrow "0"$
- Noise margin:
 - $NM_H = V_{OH} - V_{IH}$
 - $NM_L = V_{IL} - V_{OL}$

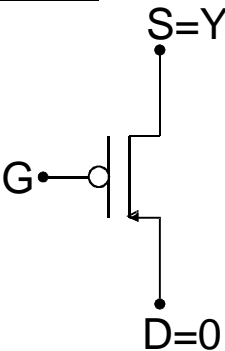


a simple switch

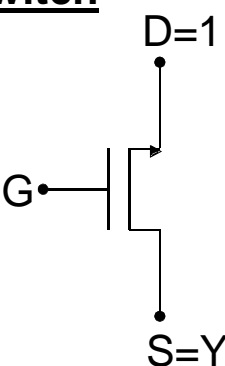


a simple switch - "bad configuration"

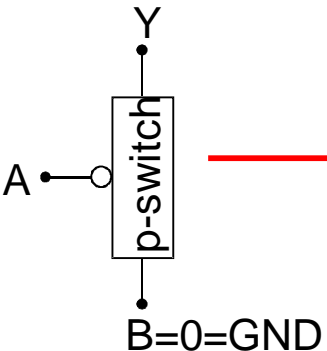
p-switch



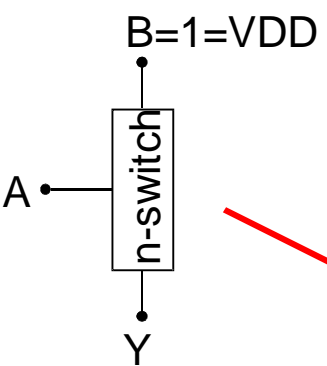
n-switch



p-switch



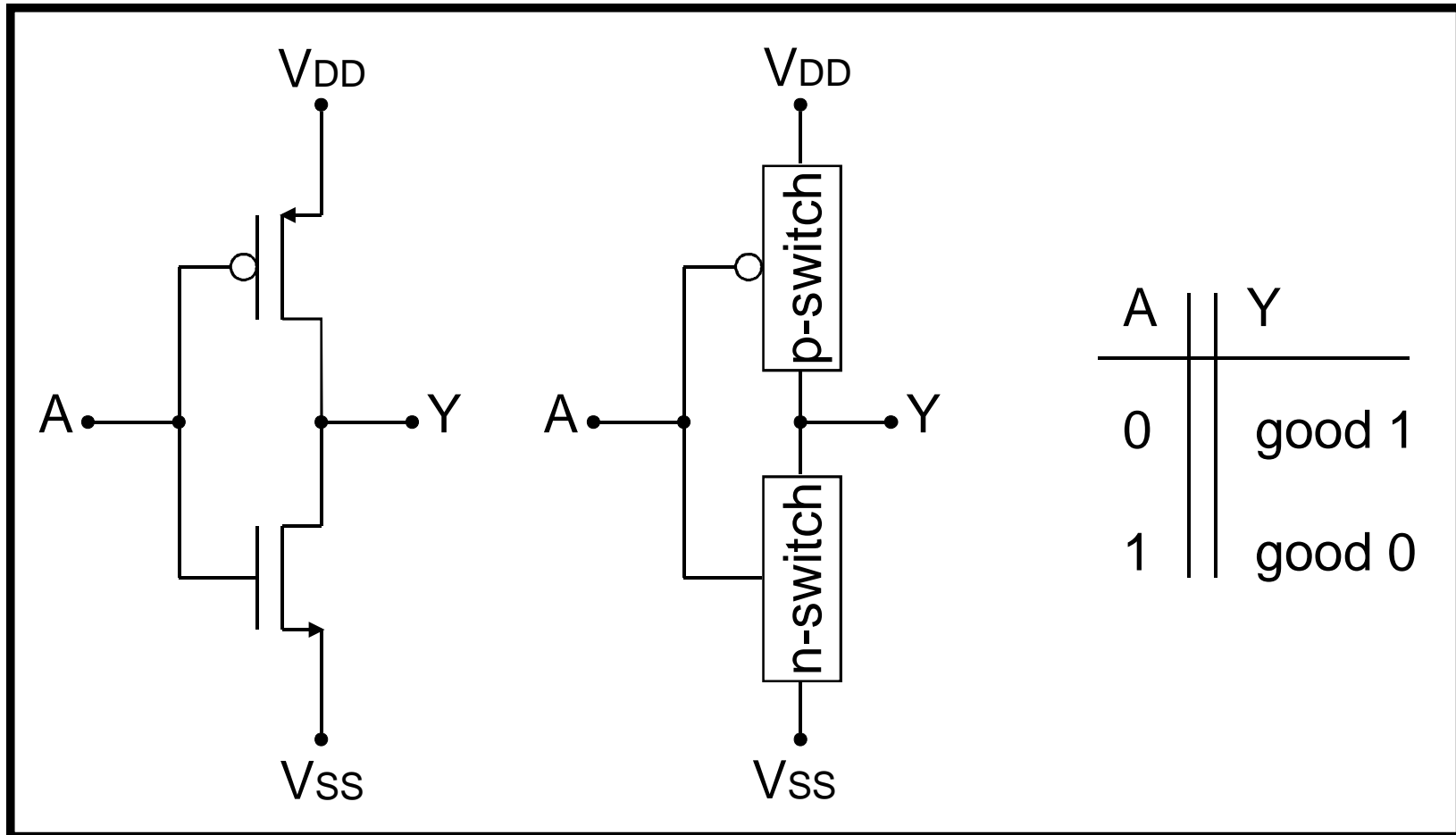
n-switch



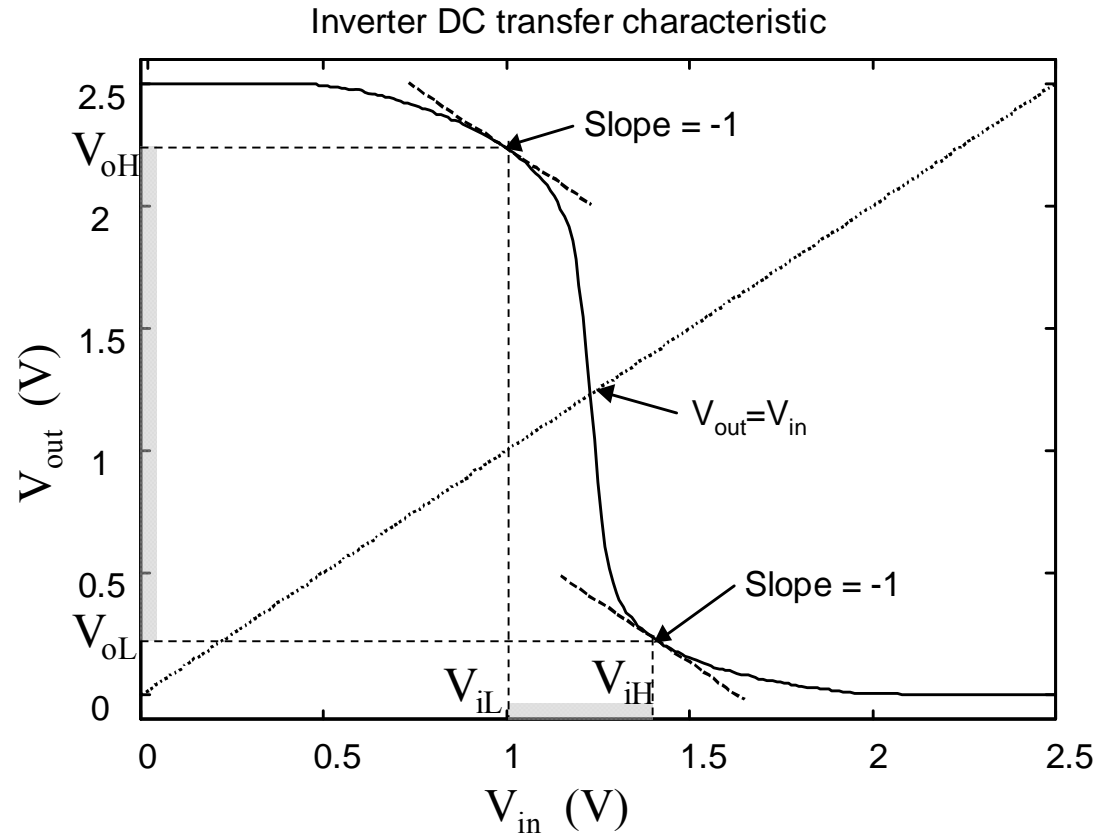
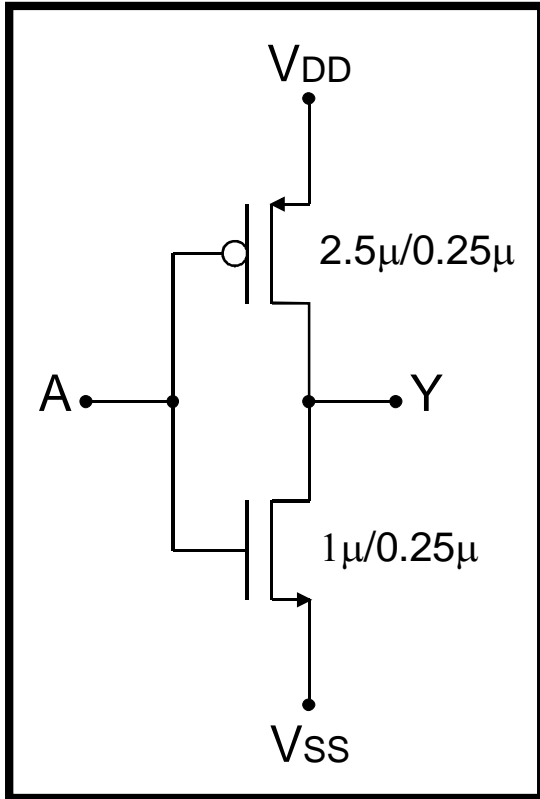
A	B	Y
0	0	bad 0 (source follower) V_{tp}
0	1	good 1
1	0	? (high Z)
1	1	? (high Z)

A	B	Y
0	0	? (high Z)
0	1	? (high Z)
1	0	good 0
1	1	bad 1 (source follower) $V_{dd} - V_{tn}$

The CMOS inverter



DC operation

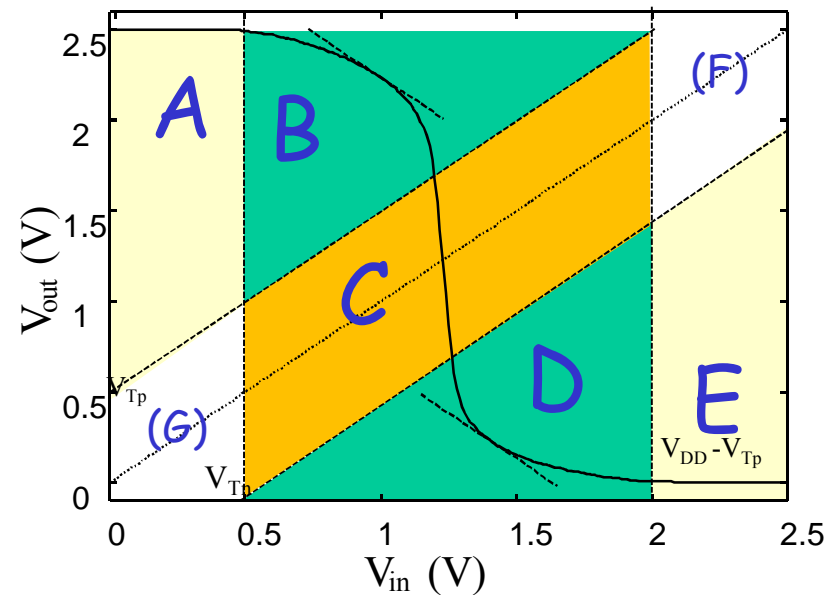
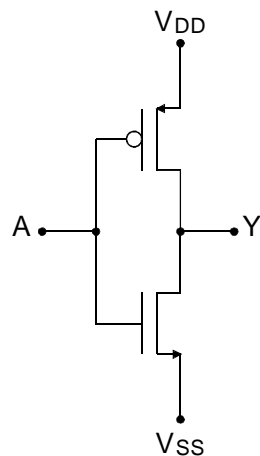


DC operation

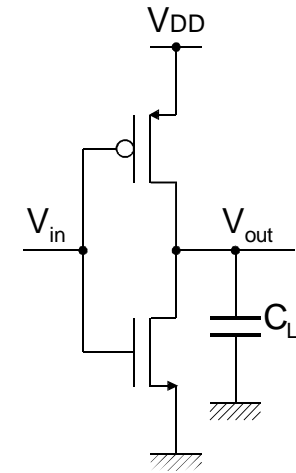
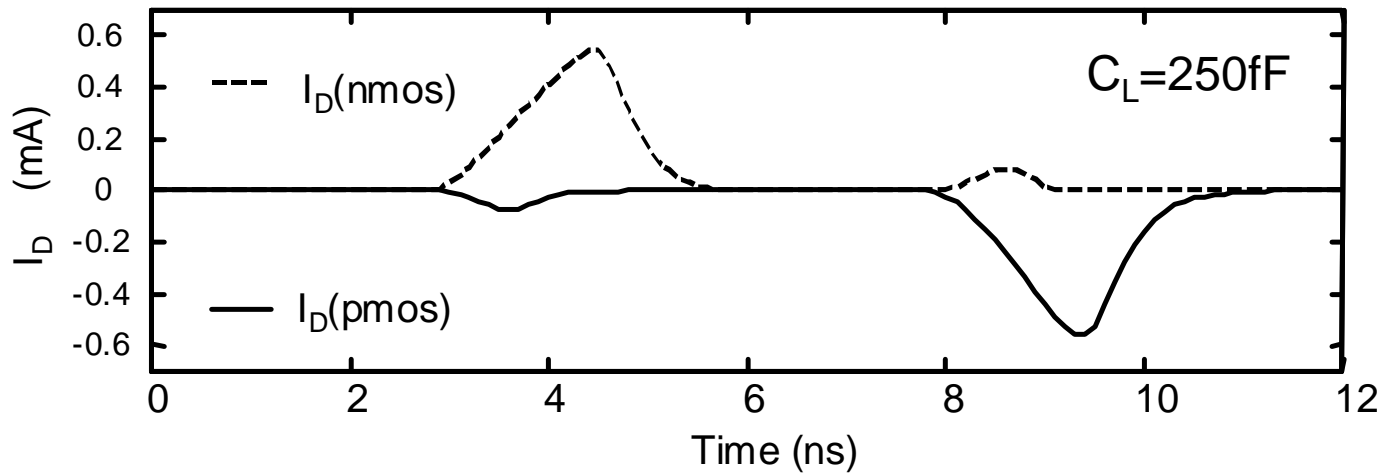
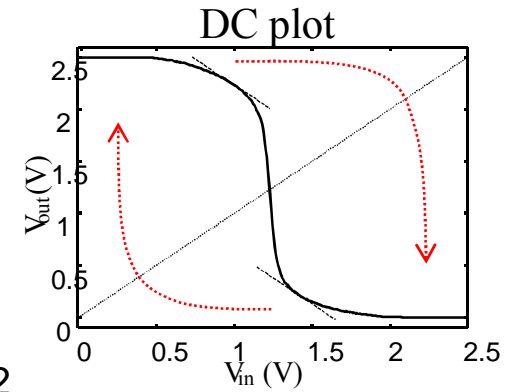
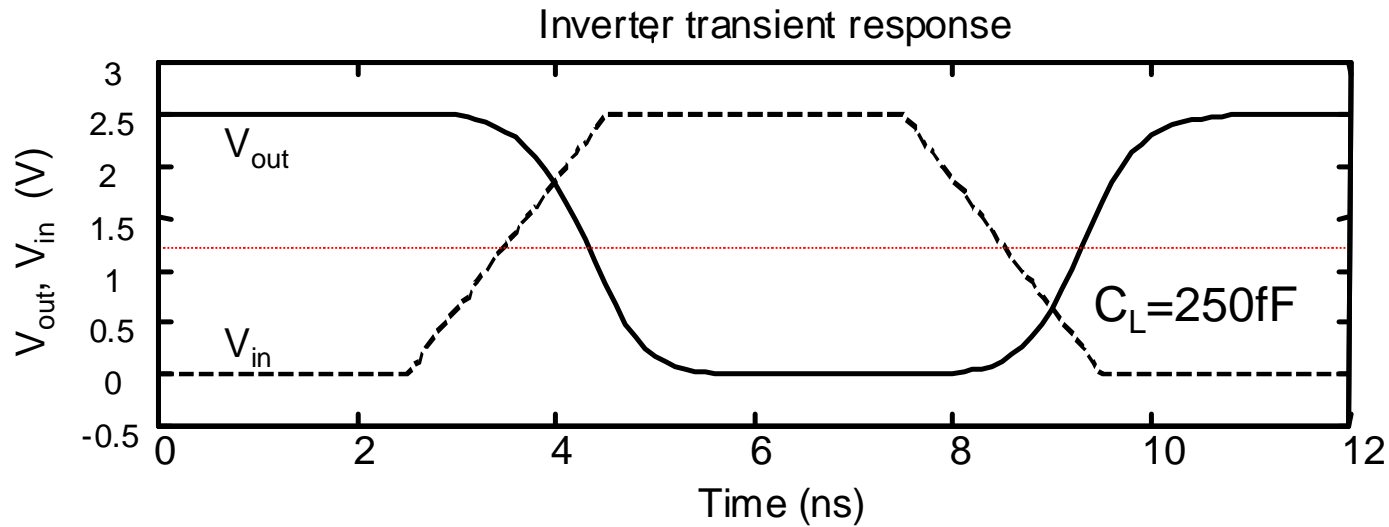
Regions of operation (balanced inverter):

V_{in}	n-MOS	p-MOS	V_{out}
A $V_{in} < V_{TN}$	cut-off	linear	V_{dd}
B $V_{TN} < V_{in} < V_{out} - V_{TP}$	saturation	linear	$\sim V_{dd}$
C $V_{out} - V_{TP} < V_{in} < V_{out} + V_{TN}$	saturation	saturation	$\sim V_{dd}/2$
D $V_{out} + V_{TN} < V_{in} < V_{dd} - V_{TP}$	linear	saturation	~ 0
E $V_{in} > V_{dd} - V_{TP}$	linear	cut-off	0

In the C zone lies most of the short-circuit current.
 -> to be avoided in transients!



Dynamic operation



Dynamic operation

- Propagation delay

- Saturation region (approx.) $I_{ds} = \frac{\mu \cdot C_{ox}}{2} \cdot \frac{W}{L} \cdot (V_{gs} - V_T)^2$
- Main origin: load capacitance

$$t_p = \frac{C_L V_{DD}}{I_{ds}}$$

$$t_{pLH} = \frac{2 \cdot C_L \cdot L_p \cdot V_{dd}}{\mu_p \cdot C_{ox} \cdot W_p \cdot (V_{dd} - |V_{TP}|)^2} \approx \frac{2 \cdot C_L}{k_p \cdot V_{dd}}$$

$$t_{pHL} = \frac{2 \cdot C_L \cdot L_n \cdot V_{dd}}{\mu_n \cdot C_{ox} \cdot W_n \cdot (V_{dd} - |V_{TN}|)^2} \approx \frac{2 \cdot C_L}{k_n \cdot V_{dd}}$$

- To reduce the delay:
 - Reduce C_L
 - Increase k_n and k_p . That is, increase W/L

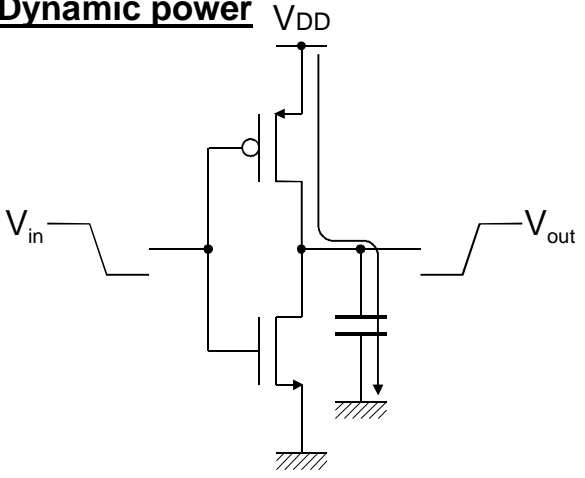
Dynamic operation

- CMOS power budget:
 - Dynamic power consumption:
 - Charging and discharging of capacitors
 - Short circuit currents:
 - Short circuit path between power rails during switching
 - Leakage
 - Leaking diodes and transistors

Dynamic operation

- The dynamic power dissipation is a function of:
 - Frequency
 - Capacitive loading
 - Voltage swing
- To reduce dynamic power dissipation
 - Reduce: C_L
 - Reduce: f
 - Reduce: $V_{dd} \Leftarrow$ The most effective action

Dynamic power



In the capacitor we store:

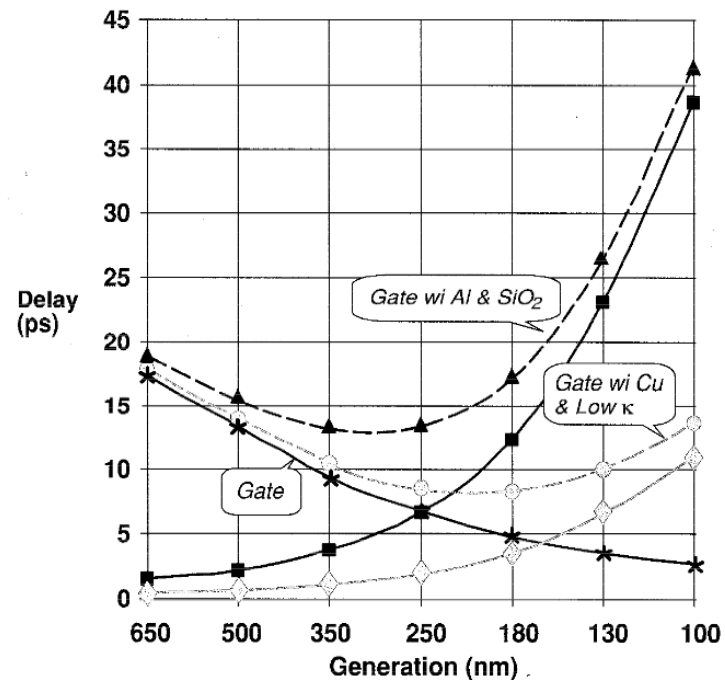
$$E = \text{Energy/transition} = \frac{1}{2} \cdot C_L \cdot V_{dd}^2$$

Another $C_L V_{dd}^2/2$ is dissipated on the PMOS when charging

$$P = \text{Power} = 2 \cdot f \cdot E = f \cdot C_L \cdot V_{dd}^2$$

Load capacitance

- Reduce: C_L
 - C_L is the sum of interconnect and transistor capacitances
 - $C_L = n_{\text{fanout}} C_{\text{gate}} + C_{\text{interconnect}} + C_{\text{drain}}$
 - An *interconnect* is a thin-film wire that electrically connects 2 or more components in an integrated circuit.
 - As transistors are scaled down in size and the number of metal wiring layers increases, the impact of interconnect parasitics increases



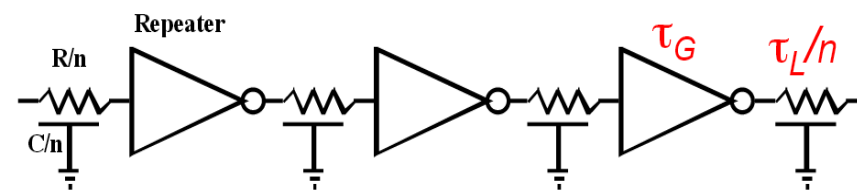
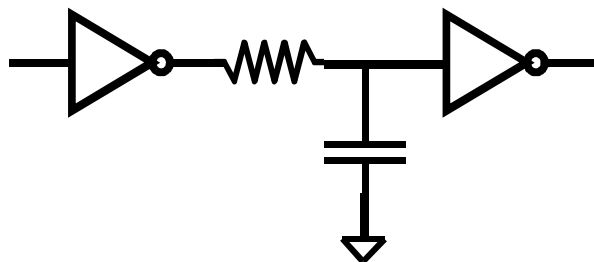
Repeaters

Metal lines run over thick oxide covering the substrate

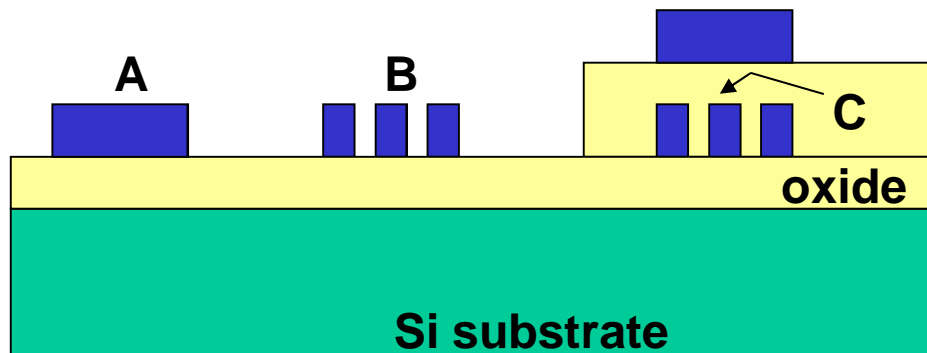
→ contribute RESISTANCE & CAPACITANCE to the output node of the driving logic gate

R and C are normally proportional to the length of the wire L, so the delay is proportional to L^2

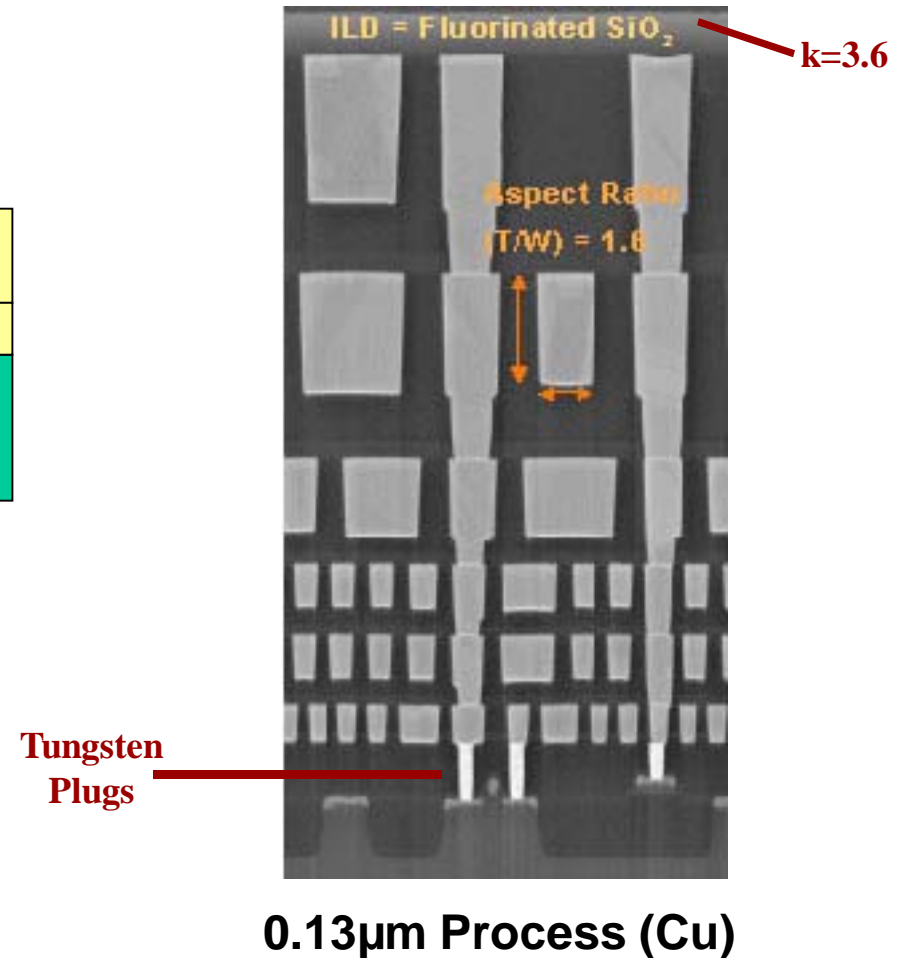
- A first option for reducing RC delays is to use better interconnect materials when they are available and appropriate.
 - Copper vs Aluminum
- For very long wires the delay can be substantially larger than the gate delay
- It is possible to reduce the propagation delay by introducing intermediate buffers



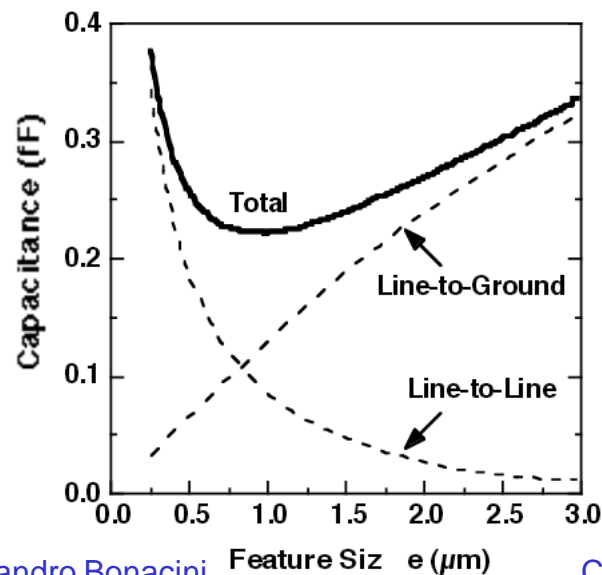
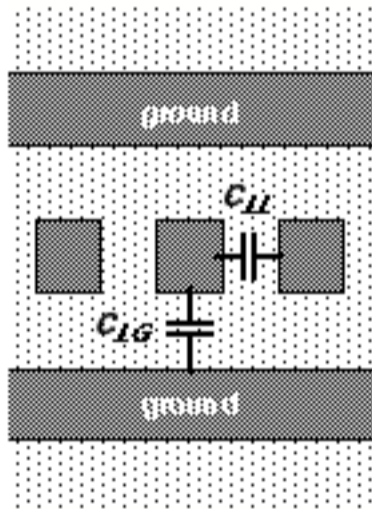
Interconnect Wire-to-Wire Capacitance



- Wire A simply has capacitance to substrate
- Wire B has additional sidewall capacitance to neighboring wires
- Wire C has additional capacitance to the wire above it

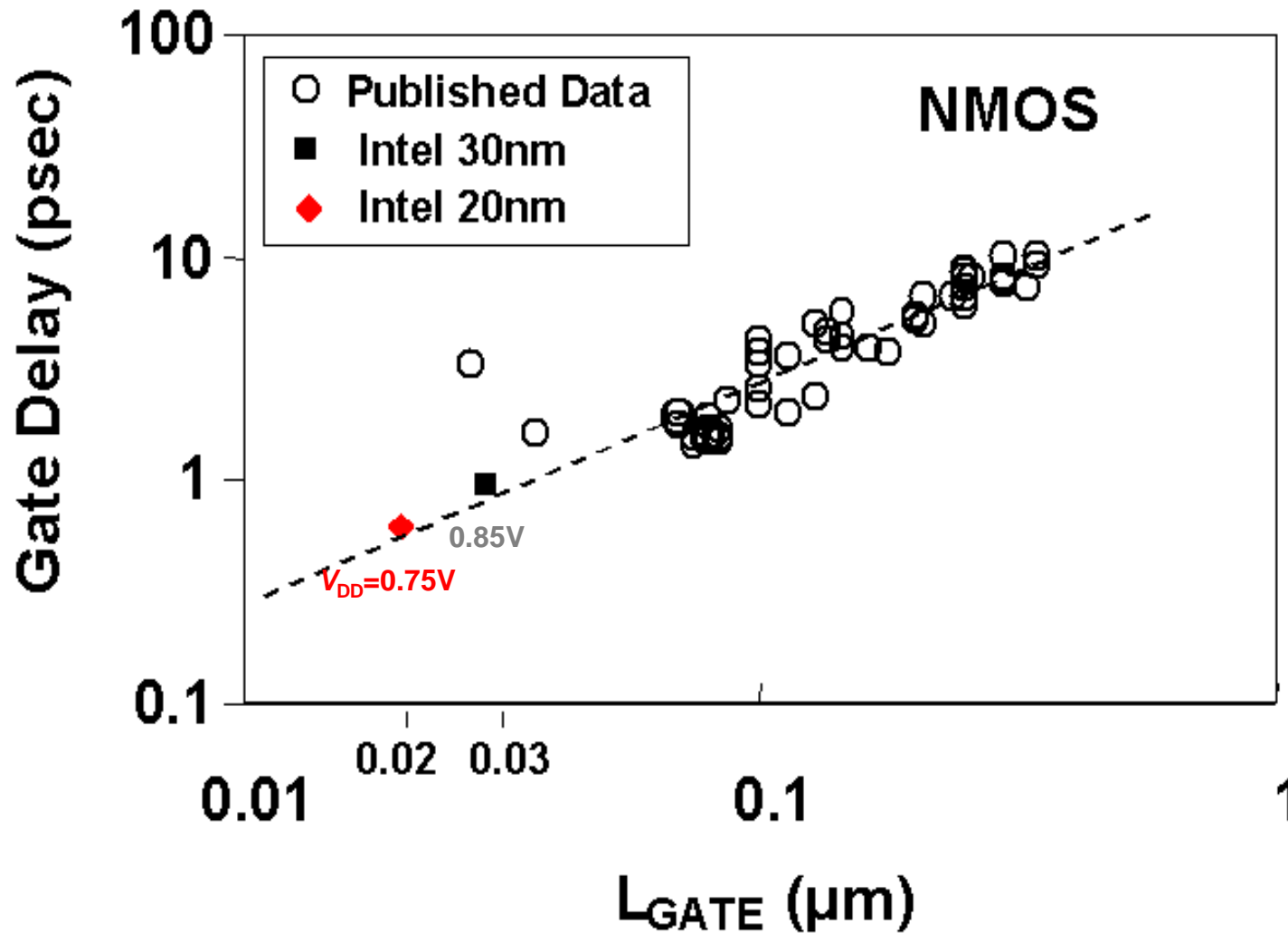


Crosstalk



- **Crosstalk**: unwanted transfer of signals from one place to another through capacitive coupling
- A possible solution is to reduce the dielectric constant of the insulator
 - Low-k materials
- Increase distance between lines for critical nets

Intrinsic Gate Delay ($C_{gate} V_{DD} / I_{DSAT}$)



Temperature dependence

- Transistor characteristics are influenced by temperature (T)

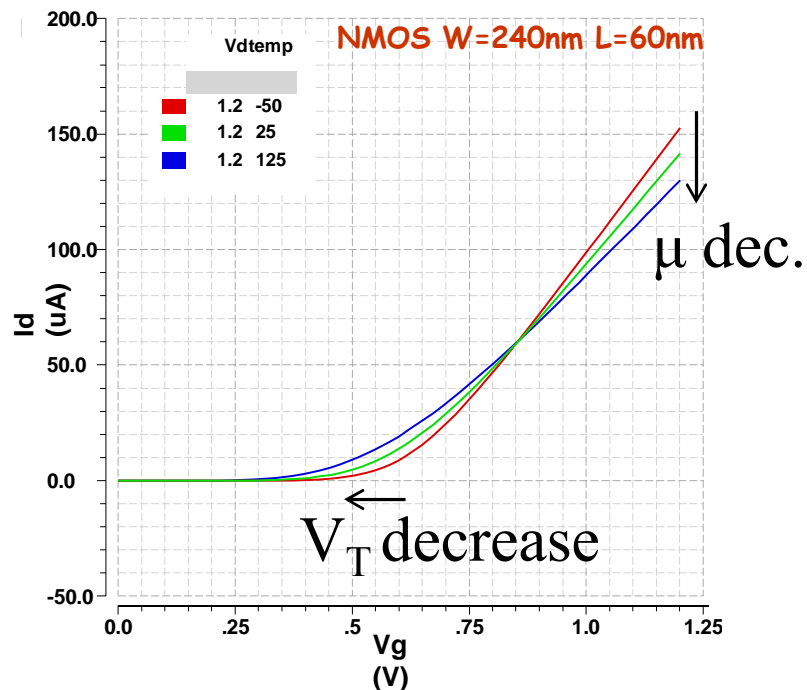
- V_T decreases linearly with T
- μ decreases with T
- $I_{leakage}$ increases with T

- Transistor performances are worst at high temperature

- Gate performance is worse at high temperature

- Interconnect resistance increase with temperature

- Interconnect capacitances normally decrease with temperature



- -> Logic blocks are slower with increasing temperature